

NANOSTRUCTURE FORMATION OF  
As<sub>x</sub>Se<sub>100-x</sub> AND Ge<sub>x</sub>Sb<sub>100-x</sub> AMORPHOUS  
FILMS UNDER CONDITIONS OF DISCRETE  
THERMAL EVAPORATION

*S. A. Kolinko, V. P. Ivanitsky<sup>1</sup>,  
V. S. Kovtunenکو, G. N. Dubrovskaya*

Cherkassy Engineering Technological Institute  
(460, Shevchenko Str., Cherkassy 257006 Ukraine),

<sup>1</sup>Uzhgorod State University  
(46, Pidgirna Str., Uzhgorod 88000, Ukraine)

S u m m a r y

We present the results of investigations by electron microscopy of a nanostructure of amorphous thin films of the As - Se and Ge - Sb systems. The dependence of a level microinhomogeneity of samples on its chemical structure and technological conditions of evaporation is found. The dependence of a nanostructure of films on the energy of adsorbed particles and composition of the vapor phase is revealed.